## FORM HDP-1449 (Based on Form PTO-1449)

## PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Sheet 1 of 2

ATTORNEY DOCKET No.	SERIAL NO.	
7784-000107/DVA	N/A	
APPLICANT		
Blackmon et al.		
FILING DATE	GROUP	
N/A	N/A	

U.S. PATENT DOCUMENTS								
Ref. Desig.	Examiner's initials	Document Number	Daté	Name	Class/ Subclass	(If appropriate) Filing Date		
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2.		3,466,473	09/09/1969	Rhoten				
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7.		5,463,374	10/31/1995	Mendez et al.	1			
8.		5,632,841	05/27/1997	Hellbaum et al.	·	\ <u> </u>		
9.		5,751,091	05/12/1998	Takahashi et al.		X ·		
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2.	V	GB 2 064 883	11/27/1979	United Kingdom					

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## FORM HDP-1449 (Based on Form PTO-1449)

## PATENT AND TRADEMARK OFFICE **Information Disclosure Citation**

(Use several sheets if necessary)

Sheet 2 of 2

ATTORNEY DOCKET No.	SERIAL NO.		
7784-000107/DVA	N/A		
APPLICANT			
Blackmon et al.			
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N/A	N/A		

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	1.	RSUT	Ibong Jung and Yongrae Roh, Design and fabrication of pieoceramic bimorph vibration sensors, Sensors and Actuators A69 (1998) 259-266.	
•	2.		F.J. von Preissig and E.S. Kim, Topics in Finite-Element Modeling of Piezoelectric MEMS.	(200
	3.		Meteer, Jami, Front-Side Processign of a Piezoelectric MEMS Accelerometer, The Pennsylvania State University National Nanofabrication Users Network, pp. 48-49	(200
	4.		Kloeppel, James E., Residual stress in piezeolectric ceramics can e reduced, put to work, News Bureau, (Sept. 1, 2000).	
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	6.		Physics and Media Group, Parasitic Power Harvesting in Shoes (Aug. 1998).	1 .
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	8.	V	USSN 10/361,533, filed 02/10/2003, entitled "Single Crystal Piezo (SCP) Apparatus And Method of Forming Same".	

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